

RESPONSE TO OFFICE ACTION
Serial No. 10/805,890
Page 1 of 7

IN THE UNITED STATES
PATENT AND TRADEMARK OFFICE
PATENT APPLICATION

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Applicant: **Nallan et al.**Case: **7017C1/ETCH/METAL-NVM/JB**Serial No.: **10/805,890**Filed: **March 22, 2004**Examiner: **Tran, Binh X**Group Art Unit: **1765**

**Title: METHOD OF PLASMA ETCHING OF HIGH-K DIELECTRIC MATERIALS WITH
HIGH SELECTIVITY TO UNDERLYING LAYERS**

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450.

CERTIFICATE OF FACSIMILE TRANSMISSION UNDER 37 C.F.R. §1.8

I hereby certify that this correspondence is being transmitted by facsimile under 37 C.F.R. §1.8 on February 13, 2006 and is addressed to Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, Facsimile No: (571) 273-8300.

2-13-06
Date

Allison M. DeVay
Signature

SIR:

RESPONSE TO OFFICE ACTION DATED NOVEMBER 23, 2005

In response to the Office Action dated November 23, 2005, having a statutory period for response set to expire on February 23, 2006, please enter this response and reconsider the claims pending in the application for reasons discussed below. The Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782 for the Terminal Disclaimer fee under 37 C.F.R. §1.20(d). Although the Applicants believe that no other fees are due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782 for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

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